

Docket No.: K5675.0034/P034  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Jong W. Kim et al.

Application No.: Not Yet Assigned

Confirmation No.: NYA

Filed: Concurrently Herewith

Art Unit: N/A

For: MASS PRODUCTION METHOD FOR  
THREE-DIMENSIONAL MICRO  
STRUCTURE HAVING HIGH ASPECT  
RATIO

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Examiner: Not Yet Assigned

**CLAIM FOR PRIORITY**

MS Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby claims priority under 35 U.S.C. 119 based on the following  
prior foreign application filed in the following foreign country on the date indicated:

<u>Country</u>	<u>Application No.</u>	<u>Date</u>
Korea, Republic of	10-2003-0078423	November 6, 2003

Application No.: Not Yet Assigned

Docket No.: K5675.0034/P034

In support of this claim, a certified copy of the said original foreign application will be filed shortly.

Dated: February 23, 2004

Respectfully submitted,

By 

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